

IDS Form PTO/SB/08: Substitute for form 1449A/PTO				Complete if Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(Use as many sheets as necessary)</i>				Application Number	10/815,932
				Filing Date	April 2, 2004
				First Named Inventor	Kouji MATSUO
				Art Unit	2811
				Examiner Name	Unknown
				Attorney Docket Number	04329.2222-01
Sheet	1	of	1		

Note: Submission of copies of U.S. Patents and published U.S. Patent Applications is not required.

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials ¹	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	Translation ⁶
<i>SL</i>		Copy of Japanese Patent Office Action, entitled "Notification of Reasons for Rejection," mailed by the Japanese Patent Office on November 29, 2005 in counterpart Japanese Application No. 11-041343	Yes
<i>SL</i>		Copy of Japanese Patent Office Action, entitled "Notification of Reasons for Rejection," mailed by the Japanese Patent Office on December 13, 2005 in counterpart Japanese Application No. 11-267207	Yes

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

O/PE Date
04/02/2004
INFORMATION DISCLOSURE CITATION

OMB No. 0651-0011

Atty. Docket No.	04329.2222-01	Div. of Appn. No.	09/492,780	10/815,932
Applicant	Kouji MATSUO, et al.			
Filing Date	April 2, 2004	Prior Group: 2814		

U.S. PATENT DOCUMENTS							
Examiner Initial*	Document Number	Issue Date	Name	Class	Sub Class	Filing Date If Appropriate	
<i>SL</i>	5,747,361	05/1998	Ouellet				
	5,801,427	09/1998	Shiratake et al.				
	5,907,188	05/1999	Nakajima et al.				
	5,936,306	08/1999	Jeng				
	5,962,904	10/1999	Hu				
	6,091,120	07/2000	Yeom et al.				
	6,147,388	11/2000	Ma et al.				
	6,162,715	12/2000	Mak et al.				
	6,208,004	03/2001	Cunningham				
	6,236,093	05/2001	Hiura				
	6,284,635	09/2001	Jang				
<i>SL</i>	6,346,438	02/2002	Yagishita et al.				

FOREIGN PATENT DOCUMENTS							
	Document Number	Publication Date	Country	Class	Sub Class	Translation Yes or No	
<i>SL</i>	DE 2940200A1	03/1981	West Germany				

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)	
<i>SL</i>	M. Wittner, et al., "Oxidation Kinetics of TiN Thin Films," J. Appl. Phys., Vol. 52, pp. 6659-6664, November (1981)
<i>SL</i>	K. Matsuo, et al., "Reliable High-k TiO ₂ Gate Insulator Formed by Ultrathin TiN Deposition and Low Temperature Oxidation," Extended Abstracts of the 1999 International Conference on Solid State Devices and Materials, pp. 164-165 (1999)

Examiner	<i>SL</i>	Date Considered	<i>10/01/04</i>
*Examiner:	Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.		
Form PTO 1449	Patent and Trademark Office - U.S. Department of Commerce		

INFORMATION DISCLOSURE CITATION

Atty. Docket No.	04329.2222-01	Appln. No.	10/815,932
Applicant	Kouji MATSUO, et al.		
Filing Date	April 2, 2004	Group:	2811

U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

A diagram consisting of a horizontal line with an arrowhead at its right end. A vertical line segment and a curved line segment both originate from a point on the left side of the horizontal line and meet at a point on the horizontal line to its right.

Examiner. <i>9</i>	Date Considered <i>2/21/06</i>
*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	